503321338 05/26/2015

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
HIROSHI ONOMOTO	05/14/2015
JITSUO HIROHATA	05/14/2015
EIKO OKAMOTO	05/14/2015
YUJI MATSUBARA	05/14/2015
MASASHI IKAWA	05/14/2015
HIDEKI MASUDA	05/14/2015
TAKASHI YANAGISHITA	05/14/2015

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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14647254

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PATENT

503321338 REEL: 035711 FRAME: 0094

ATTORNEY DOCKET NUMBER:	7412/136168
NAME OF SUBMITTER:	LOIS FORD
SIGNATURE:	/Lois Ford/
DATE SIGNED:	05/26/2015
	This document serves as an Oath/Declaration (37 CFR 1.63).

Total Attachments: 6

source=AssignmentWithDeclaration#page1.tif source=AssignmentWithDeclaration#page2.tif source=AssignmentWithDeclaration#page3.tif source=AssignmentWithDeclaration#page4.tif source=AssignmentWithDeclaration#page5.tif source=AssignmentWithDeclaration#page6.tif

Please return signed/recorded to:

Fitch, Even, Tabin & Flannery 1120 20th Street, N.W., Suite 750L Washington, D.C. 20036

INSERT

USA Patent Appln. Sole or Joint

For inventions made outside USA executed with or after application Atty. Dkt. 7412/136168 05 P - 5 8 0 6 7 US 電、電影 13

(2) Jitsuo HIROHATA

ASSIGNMENT WITH DECLARATION NONPROVISIONAL NONPROVISIONAL OF NONPROVISIONAL APPLICATION

In consideration of the sum of Ten Dollars (\$10.00) and other good and valuable consideration paid to each of the undersigned, to wit:

(1) Hiroshi ONOMOTO

INVENTOR(S)	(3) Eiko OKAMOTO	(4) Yuji MATSUBARA
	(5) Masashi IKAWA	(6) <u>Hideki MASUDA</u>
	(7) Takashi YANAGISHITA	
the receipt and sufficient assign(s) and transfer(s)		the undersigned who at the request of, hereby sell(s),
	oishi Rayon Co., Ltd.	
NAME(S) OFASSIGNEE(S)_1-1, M	Iarunouchi 1-chome, Chiyoda-ku, Tokyo	o 100-8253 Japan
& ADDRESS(ES)		
	awa Academy of Science and Technolog	xy
NAME(S) OFASSIGNEE(S) 2-1, Sa	ıkado 3-chome, Takatsu-ku, Kawasaki-s	hi, Kanagawa 213-0012 Japan
(hereinafter designated A applications including any	ASSIGNEE®) the entire right, title and interest divisions, continuations, substitutes, reissues,	t for the United States of America, in the invention and all and reexaminations thereof; and all resulting patents, known
as: METHOD FOR	PRODUCING ANODIC POROUS ALUMINA, METH	OD FOR PRODUCING MOLDED ARTICLE HAVING
MICROSCOPIO	C PATTERN ON SURFACE, AND MOLDED ARTICLE	HAVING MICROSCOPIC PATTERN ON SURFACE
	for which an application for Letters Patents	of the United States of America:
NOTE_	(A) \square was filed on even date herewith	
(Complete	(B) □ executed on	JP2013/082963, filed December 9, 2013,
line A, B and/or C)	(C) was filed on my behalf as PC1/	Jr 2015/064965, Med December 9, 2015,

AND I hereby Declare (1) the above-identified application was made or authorized to be made by me; (2) I have reviewed the above-identified application and understand the contents of the above-identified specification; (3) I acknowledge the duty to disclose information which is known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, §1.56; and (4) I believe I am the original inventor or an original joint inventor of a claimed invention in this application. I hereby acknowledge that any willful false statement in the aforesaid Declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both;

AND the undersigned hereby authorize(s) and request(s) the United States Commissioner of Patents and Trademarks to issue said Letters Patent to the said ASSIGNEE, for its interest as ASSIGNEE, its successors, assigns and legal representatives;

AND the undersigned agree(s) that the attorney of record in said application shall hereinafter act on behalf of said ASSIGNEE:

AND the undersigned hereby agree(s) to testify and execute any papers for ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE=S full protection and title in and to the invention hereby transferred.

NOTE) The undersigned hereby authorize(s) Fitch, Even, Tabin & Flannery of the above address to insert hereon any further identification necessary or desirable for recordation of this document.

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Atty. Dkt.

7412/136168

OSP-58067

(2) Jitsuo HIROHATA

NONPROVISIONAL ASSIGNMENT WITH DECLARATION NONPROVISIONAL OF NONPROVISIONAL APPLICATION

In consideration of the sum of Ten Dollars (\$10.00) and other good and valuable consideration paid to each of the undersigned, to wit:

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	(5) Masashi IKAWA	(6) <u>Hideki MASUDA</u>
	(7) <u>Takashi YANAGISHITA</u>	
the receipt and suffici- assign(s) and transfer(The state of the s	he undersigned who at the request of, hereby sell(s),
	ıbishi Rayon Co., Ltd.	
NAME(S) OF		100 0353 T
		100-8253 Japan
& ADDRESS(ES)		
INSERT Kana NAME(S) OF	gawa Academy of Science and Technology	7
ASSIGNEE(S) 2-1, S	sakado 3-chome, Takatsu-ku, Kawasaki-sh	i, Kanagawa 213-0012 Japan
& ADDRESS(ES)_		
applications including as	ny divisions, continuations, substitutes, reissues, ar	for the United States of America, in the invention and all and reexaminations thereof; and all resulting patents, known
METHOD FOR PE	RODUCING ANODIC POROUS ALUMINA, METHOD FO	OR PRODUCING MOLDED ARTICLE HAVING
MICROSCOPIC PA	ATTERN ON SURFACE, AND MOLDED ARTICLE HAVI	NG MICROSCOPIC PATTERN ON SURFACE
,	for which an application for Letters Patents of	f the United States of America:
NOTE	(A) □ was filed on even date herewith	
(Complete	(B) □ executed on	
line A, B and/or C)	(C) was filed on my behalf as PCT/J	P2013/082963, filed December 9, 2013,

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AND the undersigned agree(s) that the attorney of record in said application shall hereinafter act on behalf of said ASSIGNEE;

AND the undersigned hereby agree(s) to testify and execute any papers for ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE=S full protection and title in and to the invention hereby transferred.

<u>NOTE</u>)The undersigned hereby authorize(s) Fitch, Even, Tabin & Flannery of the above address to insert hereon any further identification necessary or desirable for recordation of this document.

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PATENT REEL: 035711 FRAME: 0101

RECORDED: 05/26/2015